



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Kazuo TESHIROGI et al.**

Group Art Unit: **TBA**

Serial No.: **10/718,653**

Examiner: Not yet assigned

Filed: **November 24, 2003**

**For: FILM LAMINATION APPARATUS AND METHOD AND A MANUFACTURING
METHOD OF A SEMICONDUCTOR APPARATUS**

Attorney Docket No.: **032131**

Customer No.: **38834**

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 5, 2004

Sir:

Please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.